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## \*BIBDATASHEET\*

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	RULE			

## APPLICANTS

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OK LVC

\*\* CONTINUING DATA \*\*\*\*\*

n/a LVC

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

n/a LVC

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 10/22/1999

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY TAIWAN	SHEETS DRAWING 3	TOTAL CLAIMS 2011	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	EXAMINER'S SIGNATURE <i>LVC</i>	INITIALS		
Verified and Acknowledged				

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## TITLE

APPARATUS AND METHOD FOR COOLING A SEMICONDUCTOR SUBSTRATE

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees
RECEIVED 760	No. _____ for following:	<input type="checkbox"/> 1.16 Fees ( Filing )
		<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
		<input type="checkbox"/> 1.18 Fees ( Issue )
		Other _____